Docket No.: 51876P541

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

Nak-Kyu Park

Application No.:

Filed:

For: Semiconductor Device for Domain

Crossing

Art Group:

Examiner:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted concurrently with the Utility Application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

-l- 51876P541

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

William Thomas Babbitt, Reg. No. 39,591

12400 Wilshire Boulevard, 7th Floor

Los Angeles, CA 90025 Telephone: (310) 207-3800

Date: 12/29/03

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known				
Application Number				
Filing Date				
First Named Inventor	Nak-Kyu Park			
Art Unit				
Examiner Name				
Attorney Docket Number	51876P541			

U.S. PATENT DOCUMENTS						
Examiner Initials*			Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US-2003/0154417 A1	08-14-2003	Drexler		
		US-2003/0117881 A1	06-26-2003	Johnson et al.		
		US-6,584,578 B1	06-24-2003	Faue		
		US-2003/0095444 A1	05-22-2003	Ryu et al.		
		US-2003/0081713 A1	05-01-2003	Pontius et al.		
		US-6,538,956 B2	03-25-2003	Ryu et al.		
		US-6,476,652 B1	11-05-2002	Lee et al.		
		US-2002/0001240 A1	01-03-2002	Ryu et al.		
		US-2003/0002357 A1	01-02-2003	Kwon et al.		
		US-6,333,896 B1	12-25-2001	Lee		
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-		,		
		US-				

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite	Foreign Patent Document			Pages, Columns, Lines,	T6	
	No.¹	Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear		
		JP 2003-132680	05-09-2003	Hynix Semiconductor Inc.			
		JP 2003-045183	02-14-2003	Hynix Semiconductor Inc.			
		JP 2002-056677	02-22-2002	HYynix Semiconductor Inc.			
		JP 2001-068650	03-16-2001	Hitachi Ltd.			
		JP 11-353878	12-24-1999	Fujitsu Ltd.			
						L	
						L	
	L						

Examiner	Date	
Signature	Considered	
	1	

Based on PTO/SB/08A (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.